

PATENT ABSTRACTS OF JAPAN

(11)Publication number : 09-171717

(43)Date of publication of application : 30.06.1997

(51)Int.Cl.

H01B 5/14
C23C 14/08
G02F 1/1333
G09F 9/30
H01J 11/00

(21)Application number : 07-333227

(71)Applicant : TOPPAN PRINTING CO LTD

(22)Date of filing : 21.12.1995

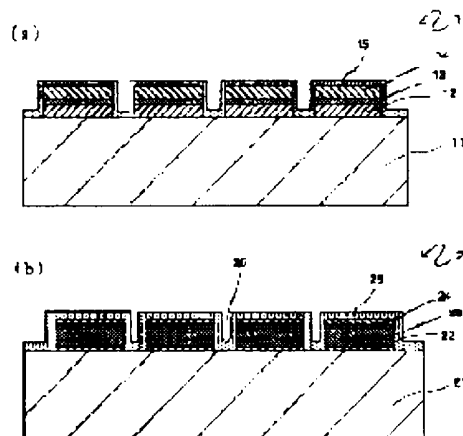
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(54) ELECTRODE SUBSTRATE

(57)Abstract:

PROBLEM TO BE SOLVED: To improve moisture resistance while keeping high transmissivity and improve moisture resistance while keeping high reflectance index by arranging an insulating film of which the refractive index is larger than a specified value on a three-layer electrode.

SOLUTION: For an electrode base board 1, a three-layer electrode is made of glass board 11, a transparent oxide film 12 as a stripe-pattern-shaped transparent electrode, a silver film 13, and a transparent oxide film 14. An insulating film 15 being cerium oxides is made to cover the pattern of this three-layer electrode, and this is made an electrode based board 1. Moisture resistance can be improved while keeping high transmissivity and moisture resistance can be improved while keeping high reflectance, by arranging it on the three-layer electrode, enlarging the refractive index of the insulating film 15 more than 2.1.



LEGAL STATUS

[Date of request for examination]

24.09.1996

[Date of sending the examiner's decision of rejection]

[Kind of final disposal of application other than the examiner's decision of rejection or application converted registration]

[Date of final disposal for application]

[Number of appeal against examiner's decision of rejection]

[Date of requesting appeal against examiner's
decision of rejection]

[Date of extinction of right]

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CLAIMS

[Claim(s)]

[Claim 1] The electrode substrate which arranges an insulator layer with a larger refractive index than 2.1 on the above-mentioned electric conduction film, and is characterized by the bird clapper in the electrode substrate equipped with the electric conduction film of composition of pinching a silver system thin film by the transparent oxide thin film on a substrate.

[Claim 2] The electrode substrate according to claim 1 characterized by the base material of the above-mentioned insulator layer being a cerium oxide.

[Claim 3] The electrode substrate according to claim 1 or 2 characterized by being in the range whose thickness of the above-mentioned insulator layer is 1nm - 70nm.

[Claim 4] The electrode substrate according to claim 1, 2, or 3 characterized by being in the range whose thickness of the above-mentioned silver system thin film is 4nm - 17nm.

[Claim 5] The electrode substrate according to claim 1, 2, or 3 characterized by being in the range whose thickness of the above-mentioned silver system thin film is 50nm - 200nm.

[Claim 6] The electrode substrate

transparent oxide thin film is characterized by being the mixed oxide of a cerium oxide and indium oxide.

[Claim 7] The electrode substrate according to claim 1, 2, 3, 4, or 6 characterized by arranging the light filter between the above-mentioned substrate and an electric conduction film.

DETAILED DESCRIPTION

[Detailed Description of the Invention]

[0001]

[The technical field to which invention belongs] With respect to the transparent electrode or reflector the electrode substrate of transparent electrodes for display, such as a liquid crystal display, an I/O device, or a plasma display, or a reflector, or for solar batteries, especially this invention has conductivity and high visible-ray permeability at a thin film, and relates to the electrode substrate which was moreover excellent in preservation stability.

[0002]

[Description of the Prior Art] The electrode board with which the transparent electric conduction film of the electrode configuration which penetrates a visible ray was prepared on substrates, such as glass and plastic film, is widely used for the I/O electrode which carries out a direct input from the display

display, or this display. For example, the transparent-electrode board of the display unit with which liquid crystal was used. The light-filter layer 37 which is prepared in the pixel part on a glass substrate 31 and this glass substrate 31, and colors the transmitted light red, green, and blue for every pixel, respectively as shown in drawing 2. The shading film 38 which is prepared in the part between the pixels on the above-mentioned glass substrate 31 (part between pixels), and prevents the light transmission from this part. The principal part consists of a protective layer 39 prepared all over the above-mentioned light-filter layer 37, a transparent electrode 40 formed on this protective layer 39, and an orientation film 41 formed on this transparent electrode 40. And membranes are formed by sputtering and the above-mentioned transparent electrode 40 is constituted by the transparent electric conduction coat which *****ed to the predetermined pattern.

[0003] The ITO thin film which added the tin oxide in indium oxide as this transparent electric conduction coat paying attention to the high conductivity is used widely, the specific resistance is 2.4×10^{-4} ohm-cm about, and, in the case of the 240nm thickness usually applied as a transparent electrode, the sheet resistivity is about 10ohm/**. Moreover, although the tin-oxide thin film, the thin

film (Nesa membrane) constituted by this tin oxide by adding an antimony oxide, the thin film constituted by the zinc oxide by adding an aluminum oxide are known in addition to this, each of these is inferior to the above-mentioned ITO thin film in the conductivity, and neither an acid, nor chemical resistance or water resistance to alkali has inadequate hatchet spread [general].

[0004] The transparent electric conduction film of the three-tiered structure which the front rear face of a silver thin film is made to carry out the laminating of an ITO thin film or the indium oxide thin film (IO thin film) as a heat ray reflective film, and is constituted in the 7thICVM held in Japan in 1982 on the other hand is proposed. The transparent electric conduction film of this three-tiered structure has the low sheet resistivity about about 5ohms / **, and the application to the above-mentioned transparent electrode was expected taking advantage of the high conductivity.

[0005]

[Problem(s) to be Solved by the Invention] By the way, in the above-mentioned display unit or the I/O device, it is required that increasing pixel density and displaying a precise screen in recent years should be called for, and precise-ization of the above-mentioned transparent-electrode pattern should be demanded in connection with this, for

example, the terminal area of the above-mentioned transparent electrode should be constituted from a pitch which is about 100 micrometers. Moreover, in the method (COG) with which the direct file of the IC for a liquid crystal drive is carried out to a substrate in liquid crystal display equipment, there is a portion from which leading about of wiring serves as a thin line called width of face of 20-50 micrometers, and the advanced etching processing suitability which is not in the former, and high conductivity (low resistivity) are demanded.

[0006] Moreover, in order to also call for enlargement of the display screen on the other hand, to form the transparent electrode of a precise pattern which was mentioned above about such big screen-ization and to enable it to impress sufficient driver voltage for liquid crystal moreover, the transparent electric conduction film equipped with the high conductivity below 5ohms / **, as the above-mentioned transparent electrode needed to be applied, moreover -- in addition, in performing the multi-gradation display of 16 or more gradation in the liquid crystal display of the simple matrix drive method using STN LCD etc., it calls it below 3ohms / ** -- low sheet resistivity is demanded further

[0007] However, also in the transparent

proposed in the 7thICVM, the sheet resistivity about at most 5ohms / ** did not pass to be obtained, but there was a trouble that sufficient conductivity was not securable. In addition, although it is possible to reduce the sheet resistivity to about 3ohms / ** by making thickness of a silver thin film thick to about 16-18nm, visible-ray permeability (especially a long wave with a wavelength of about 610nm visible-ray permeability by the side of merit) will fall to about 75%, and the function as a transparent electric conduction film will be spoiled.

[0008] furthermore, the moisture in the air into which the silver thin film advanced from the laminating interface etc. in the transparent electric conduction film of the above-mentioned three-tiered structure -- combining -- easy -- the front face -- a reactant -- generating -- silverfish -- when the defect of a ** was produced, for example, it applied to the transparent electrode of a liquid crystal display, the trouble of being easy to produce a display defect etc. was shown in the front face It is in offering the transparent electric conduction film which this invention is made paying attention to such a trouble, and conductivity and whose visible-ray permeability are [the place made into the technical problem] high at a thin film, moreover does not have degradation with

[0009] On the other hand, in the transparent electrode for solar batteries, hydrogen plasma resistance is needed due to the manufacture process. For this reason, it is common to use the transparent electrode which makes a base material the high zinc oxide of hydrogen plasma resistance. However, what carried out the fluorine dope, and the thing which carried out alumina addition also had high resistance, and the transparent electrode of a zinc-oxide system needed to form it in 400nm - 800nm and quite thick thickness as a transparent electrode for solar batteries.

[0010] This invention persons have proposed the electrode substrate in which the electric conduction film of composition of pinching the silver system thin film which considers as the electrode substrate which can solve these problems mostly, for example, contains 0.1-3at% copper by the transparent oxide thin film was formed. However, although practical use level had this composition mostly, its moisture resistance was a little inadequate. copper -- 1at% -- when the electrode substrate with an electric conduction film (it abbreviates to a three-layer electrode hereafter) of composition of pinching the silver system thin film to contain by the transparent oxide thin film was kept under 60 degrees C. and 95% high-humidity/temperature environment of humidity, the problem which minute silverfish generates was in

the pattern before or after about 200 hours

[0011]

[Means for Solving the Problem] When this invention persons repeated examination wholeheartedly in view of the above technical technical problems, it discovered obtaining a result with the sufficient composition which formed the insulator layer which is excellent a high refractive index and chemical-resistant on the three-layer electrode as a protective coat. About a refractive index, a similarly high thing is desirable also in the transparent oxide thin film which pinches not only a protective coat but a silver system thin film. In the case of the three-layer electrode of the gestalt which touches liquid crystal material (the refractive index of the usual liquid crystal is 1.5 to about 1.6) and a light filter (grade to which the refractive index of the material of a light filter exceeds 1.5 a little) with a refractive index higher than air, this inclination is remarkable.

[0012] For example, although B line of drawing 4 shows a simulation result in case one side of the three-layer electrode formed on substrates, such as glass, is air, in permeability T, a reflection factor R falls 96% or more at a peak till the place near 1%. Here, thickness of the transparent oxide thin film of the side which touches 40nm in the thickness of the transparent oxide thin film by the side of a substrate, and touches 14nm

and air in Ag thickness was set to 44nm. The refractive index of a transparent oxide thin film was calculated as the 2.0 [almost same] as ITO. However, 40nm laminating of the orientation film of a polyimide is carried out on a three-layer electrode, and if the refractive index of the liquid crystal which touches this is recalculated as 1.5, as shown in A of drawing 4, permeability T and a reflection factor R will become quite bad. The peak of permeability will be less than 90%, and a reflection factor R will rise to about 10% near the wavelength of 550nm of light.

[0013] From this, this invention persons changed the refractive index of a transparent oxide thin film into the three-layer electrode, and performed calculation in the form where the polyimide film and liquid crystal as an orientation film of liquid crystal touch to it (while changing the refractive index, the thickness of the transparent oxide thin film which pinches a silver system thin film was also adjusted, and it optimized mostly). A result is shown in drawing 3. It turns out that permeability will improve if the one where the refractive index of a transparent oxide thin film is higher exceeds especially 2.1, and a reflection factor also falls.

[0014] Thus, this invention persons have found out that optimization of the

transparent oxide thin film corresponding to the thickness of a silver system thin film. This invention persons discovered further that this transparent oxide thin film could replace a part by the insulator layer of a high refractive index. It discovered collectively that the reliability of a three-layer electrode improved greatly by the replacement by the insulator layer. That is, invention concerning a claim 1 is an electrode substrate which arranges an insulator layer with a larger refractive index than 2.1 on the above-mentioned electric conduction film, and is characterized by the bird clapper in the electrode substrate equipped with the electric conduction film of composition of pinching a silver system thin film by the transparent oxide thin film on a substrate.

[0015] A cerium oxide has the very high refractive index of about 2.5 for strong alkali resistance more nearly simultaneously. In the form where it substitutes for a part of thickness of a transparent oxide thin film, the insulator layer which makes a cerium oxide a base material can be used. That is, invention concerning a claim 2 is an electrode substrate according to claim 1 characterized by the base material of an insulator layer being a cerium oxide. In a cerium oxide, you may add the oxide of

and alkali resistance, and an oxidization gallium, a tin oxide.

[0016] It is appropriate for formation of an insulator layer to set the thickness as the range of 1nm - 70nm. Although it may be thinner than 1nm, if it takes into consideration in accordance with the effect (it will be tended with this as the starting point to destroy moisture etc. the composition if a three-layer electrode has a minute defect) of burying the thickness control at the time of membrane formation, and the defective part of a three-layer electrode, 1nm is required at least. Consideration of permeability and a reflection factor of the thickness of one side of the transparent oxide thin film of a three-layer electrode chooses it from the range of 20nm - 70nm in general. The maximum thickness of an insulator layer is good at 70nm noting that it substitutes for the transparent oxide thin film in an insulator layer. That is, it is the electrode substrate according to claim 1 or 2 characterized by the range whose thickness of an insulator layer is 1nm - 70nm having invention concerning a claim 3.

[0017] As a result of repeating research still more deeply, this invention persons found out that there was a suitable range for the thickness of a silver system thin film, when the refractive index of a transparent oxide thin film was made high. The simulation result at the time of setting the refractive index of a

transparent oxide thin film to 2.3, and setting [the thickness of the transparent oxide thin film by the side of a glass substrate ($n=1.5$) / the thickness of 35nm and a silver system thin film / the thickness of 12nm and the upper transparent oxide thin film] the refractive index of 40nm and a medium (liquid crystal is assumed) to 1.5 for the thickness of 37nm and a polyimide film was shown in drawing 5. The thinner one of the thickness of a silver system thin film has high permeability, and a reflection factor becomes low and shows the good inclination. When the thickness of a silver system thin film becomes thicker than 17nm, it turns out that it becomes difficult, as for permeability with a wavelength [of light] of 550nm, to maintain 90% or more, and there is the need of forming more thinly than 17nm. Moreover, if a silver system thin film is made thinner than 4nm, a homogeneous film will be hard to be formed in practice, and it will turn into island-like ****. When thinner than 4nm, since a reflection factor increases by such reason, as for the thickness of a silver system thin film, it is desirable to make it thicker than 4nm. In addition, of course with the composition which makes the light source of high brightness a back light a premise [penetrated type LCD], you may form a silver system thin film thickly from 17nm. That is, it is the electrode substrate according to claim 1, 2, or 3 characterized

by the range whose thickness of a silver system thin film is $4\text{nm} \sim 17\text{nm}$ having invention concerning a claim 4.

[0018] Moreover, in a three-layer electrode, if the thickness of a silver system thin film is formed more thickly than 50nm , it will become a reflector with the high reflection factor of light. A reflector can be used as the reflector which served both as the reflecting plate and the drive electrode with the reflected type liquid crystal display, or a reflective film of the light which is a solar battery and is formed in a semiconductor device rear face in order to raise a photoelectric conversion efficiency. 2.3 is carried out for the refractive index of 1.5 and a transparent oxide thin film, and the simulation of the thickness of a silver system thin film is carried out [the refractive index whose drawing 6 is a medium] for thickness as 50nm , 75nm , 100nm , and 200nm in 40nm . If the thickness of a silver system thin film exceeds 50nm , it will become a reflection nature electrode around 80%, and a reflection factor is saturated with 200nm , and about 0% and the bird clapper are shown also for permeability. That is, it is the electrode substrate according to claim 1, 2, or 3 characterized by the range whose thickness of a silver system thin film is $50\text{nm} \sim 200\text{nm}$ having invention concerning a claim 5.

transparent, it may be a substrate colored the color of white, and black and others. The quality of the material can also use various things, such as a substrate in which the semiconductor device of glass, plastic film, a ceramic, a metal, or an amorphous silicon was formed.

[0020] By the way, the conventional three-layer electrode represented by the composition of $[\text{ITO}/\text{Ag}/\text{ITO}]$ has a big problem in moisture resistance. Moreover, since a refractive index is 1.8 to about 2.0, ITO cannot offer a highly efficient three-layer electrode. This invention persons found out that the composition using the mixed oxide of a cerium oxide and indium oxide as a transparent oxide thin film of a three-layer electrode was extremely excellent in moisture resistance and an optical property, as a result of examining various oxides. That is, it is the electrode substrate according to claim 1, 2, 3, 4, or 5 to which invention concerning a claim 6 is characterized by the base material of a transparent oxide thin film being the mixed oxide of a cerium oxide and indium oxide.

[0021] The transparent oxide thin films by this mixed oxide are the metallic element conversion (an oxygen element is not counted) contained as an oxide, and can offer the electrode substrate mostly equipped with the electric conduction

than 5at% and by adding to more than 20at% and indium oxide preferably. When pattern formation is required as a three-layer electrode and it is premised on wet etching, as for the addition of a cerium element, less than [40at%] is good. When it comes to more than 40at%, the pattern formation in wet etching becomes a little difficult. In the case of dry etching, this problem does not exist at the addition beyond 40at%, either. Moreover, when pattern formation is unnecessary, it is good also as a mixed oxide in the level which exceeds 40at(s)% for a cerium element. The refractive index of a transparent oxide thin film turns into a high refractive index as the rate of a cerium oxide becomes high. It was [in this invention persons' data] $n = 2.49$ at $n = 2.30$ and 100at% in $n = 2.24$ and 40at% by $n = 2.17$ and 30at% at cerium 20at%. In addition, these refractive indexes are influenced according to the partial pressure of the oxygen gas at the time of membrane formation, the annealing-temperature conditions after membrane formation, etc.

[0022] The electrode substrate by this invention makes color display possible by arranging the light filter colored red, green, blue, etc. between the substrate and the three-layer electrode which is a transparent electrode, when using as an electrode substrate for display. That is, invention concerning a claim 7 is an electrode substrate according to claim 1,

2, 3, 4, or 6 characterized by arranging the light filter between a substrate and an electric conduction film.

[0023]

[Embodiments of the Invention] The gestalt of operation of this invention is stated to the following examples.

[0024]

[Example] Hereafter, the example of this invention is explained in detail with reference to a drawing.

<Example 1> the electrode substrate 1 concerning this example As shown in drawing 1 (a), as the glass substrate 11 with a thickness of 0.7mm and a stripe pattern-like transparent electrode The transparent oxide thin film 12 with a thickness of 40nm. The silver system thin film 13 with a thickness of 15nm, the transparent oxide thin film 14 with a thickness of 40nm, and the insulator layer 15 that is a cerium oxide with a thickness of 2nm as the pattern of this three-layer electrode is covered were formed, and it considered as the electrode substrate for liquid crystal displays.

[0025] the transparent oxide thin films 12 and 14 -- each -- metallic element conversion (an oxygen element is not counted) -- a cerium -- 30at(s)% -- it considered as the mixed oxide of the cerium oxide and indium oxide which are included a silver system thin film -- copper -- 0.8at(s)% -- it considered as the included silver copper alloy All form membranes in sputtering and carry out

pattern formation in wet etching. The insulator layer 15 which is a cerium oxide formed membranes in sputtering similarly. The sheet resistivity values of the three-layer electrode of this example were $2.8\text{ohm}/\square$, and the permeability in a glass reference (a medium is air) was about 97% in 550nm.

[0026] both the naked eye after keeping the electrode substrate of this example under 60 degrees C and the environment of 95% of humidity for 200 hours, and a microscope -- when appearance was investigated by the method, change was not produced at all Resistance and permeability were also changeless. Although the electrode substrate which has not carried out the laminating of the insulator layer 15 was put on the bottom of this environment as an example of comparison for 200 hours, when appearance was investigated, silverfish and the defect of several micrometers - 20 micrometer size appeared here and there near the edge of a stripe pattern.

[0027] <Example 2> the electrode board 2 concerning this example As shown in drawing 1 (b), as the glass substrate 21 with a thickness of 0.7mm and a stripe pattern-like reflector The transparent oxide thin film 22 with a thickness of 10nm, the silver system thin film 23 with a thickness of 150nm, the transparent oxide thin film 24 with a thickness of

the pattern of this three-layer electrode is covered were formed, and it considered as the electrode substrate for reflected type liquid crystal displays, the transparent oxide thin films 22 and 24 -- each -- metallic element conversion (an oxygen element is not counted) -- a cerium -- 30at(s)% -- it considered as the mixed oxide of the cerium oxide and indium oxide which are included a silver system thin film -- copper -- 0.8at(s)% -- it considered as the included silver copper alloy Each of others and membrane formation methods and pattern formation methods is the same as that of an example 1. The sheet resistivity values of the three-layer electrode of this example were about $0.2\text{ohm}/\square$, and the reflection factor in a barium-sulfate reference was about 93% in 550nm.

[0028] both the naked eye after keeping the electrode substrate of this example under 60 degrees C and the environment of 95% of humidity for 200 hours, and a microscope -- when appearance was investigated by the method, change was not produced at all Resistance and permeability were also changeless. Although the electrode substrate which has not carried out the laminating of the insulator layer 15 was put on the bottom of this environment as an example of comparison for 200 hours, when appearance was investigated, silverfish

near the edge of a stripe pattern.

[0029] In addition, in an example 2, although thickness of an insulator layer 25 was set to 40nm, in order to harness the reflected light from the space 26 between three-layer the patterns of an electrode, you may form before and after 50nm - 60nm still more thickly. By forming the cerium oxide of a high refractive index thickly, the reflected light component from other than the pattern section can increase, and further improvement in brightness of a reflected type liquid crystal display can be aimed at. The substrate in which the cerium oxide of 50nm ** was formed on the glass side has about 30 - 40% of reflection factor. In the substrate which did not form a cerium oxide but the glass substrate exposed in portions other than a pattern on the other hand, it is 5 - 6% of reflection factor. On the contrary, although it is necessary to stop the reflective component from the space section in the case of a penetrated type liquid crystal display, if thickness of a cerium oxide is set to 5nm or less and made to form, a reflection factor almost of the same grade only as a glass substrate can be obtained.

[0030]

[Effect of the Invention] According to this invention, moisture resistance can be improved, maintaining high permeability in a transparent electrode, in order to arrange an insulator layer with a larger

refractive index than 2.1 on a three-layer electrode. Moreover, moisture resistance can be improved in a reflector, with a high reflection factor maintained. Moreover, as an electrode substrate for reflected type liquid crystal displays of a normally white display, since the reflection from for example, the space section of those other than an electrode pattern is also expectable, further improvement in brightness is achieved. Moreover, since a part of thickness of a transparent oxide thin film can be replaced by the cerium oxide, the amount of the expensive indium oxide used can be reduced.

[0031]

DESCRIPTION OF DRAWINGS

[Brief Description of the Drawings]

[Drawing 1] It is the cross section of the electrode substrate concerning [concerning an example 1 in (a)] an example 2 in (b), respectively.

[Drawing 2] It is the cross section showing an example of the transparent-electrode board used for a liquid crystal display.

[Drawing 3] It is the graph which shows the spectral reflectance and spectral transmittance at the time of changing the refractive index of a transparent oxide thin film of the electrode substrate concerning this invention.

[Drawing 4] In the simulation of an

electrode substrate, it is the graph which shows the difference of the spectral characteristic at the time of being a time of the refractive index of a medium being 1, and 1.5.

[Drawing 5] It is the graph which shows the spectral characteristic at the time of changing the thickness of a silver system thin film of the electrode substrate concerning this invention in a thin field.

[Drawing 6] It is the graph which shows the spectral characteristic at the time of changing the thickness of a silver system thin film of the electrode substrate concerning this invention in a thick field.

[Description of Notations]

11 21 : Substrate

12, 14, 22, 24 : Transparent oxide thin film

13 23 : Silver system thin film

15 25 : Insulator layer

(19) 日本国特許庁 (J P)

(12) 公開特許公報 (A)

(11) 特許出願公開番号

特開平9-171717

(43) 公開日 平成9年(1997)6月30日

(51) Int.Cl. ⁶	識別記号	庁内整理番号	F I	技術表示箇所
H 0 1 B 5/14			H 0 1 B 5/14	A
C 2 3 C 14/08			C 2 3 C 14/08	N
G 0 2 F 1/1333	5 0 5		G 0 2 F 1/1333	5 0 5
G 0 9 F 9/30	3 1 5		G 0 9 F 9/30	3 1 5
H 0 1 J 11/00			H 0 1 J 11/00	Z
審査請求 有 請求項の数 7 O L (全 7 頁)				

(21) 出願番号 特願平7-333227

(22) 出願日 平成7年(1995)12月21日

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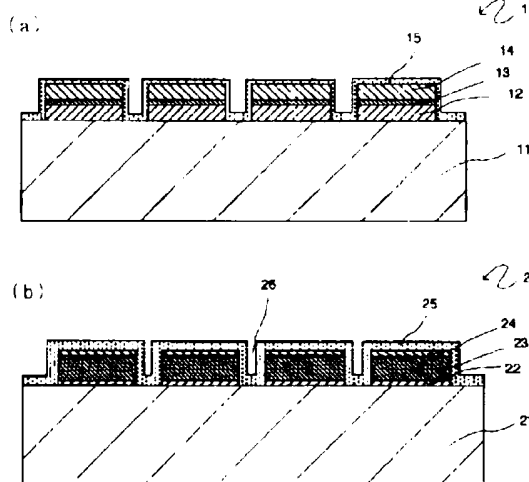
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(54) 【発明の名称】 電極基板

(57) 【要約】

【課題】 薄膜で導電性と可視光線透過率が高く、しかも経時劣化がなく保存安定性に優れた透明導電膜を提供する。

【解決手段】 基板上に銀系薄膜を透明酸化物薄膜で扶持する構成の導電膜を備える電極基板において、上記導電膜上に屈折率が2.1より大きい絶縁膜を配設してなる。



1

【特許請求の範囲】

【請求項1】基板上に銀系薄膜を透明酸化物質薄膜で扶持する構成の導電膜を備える電極基板において、上記導電膜上に屈折率が2-1より大きい絶縁膜を配設してなることを特徴とする電極基板。

【請求項2】上記絶縁膜の基材が酸化セリウムであることを特徴とする、請求項1記載の電極基板。

【請求項3】上記絶縁膜の膜厚が1nm〜70nmの範囲にあることを特徴とする、請求項1または請求項2記載の電極基板。

【請求項4】上記銀系薄膜の膜厚が4nm〜17nmの範囲にあることを特徴とする、請求項1、2または3記載の電極基板。

【請求項5】上記銀系薄膜の膜厚が50nm〜200nmの範囲にあることを特徴とする、請求項1、2または3記載の電極基板。

【請求項6】上記透明酸化物質薄膜の基材が、酸化セリウムと酸化インジウムとの混合酸化物質であることを特徴とする、請求項1、2、3、4または5記載の電極基板。

【請求項7】上記基板と導電膜との間にカーボンペーストが配設されていることを特徴とする、請求項1、2、3、4または6記載の電極基板。

【発明の詳細な説明】

【0001】

【発明の属する技術分野】本発明は、液晶ディスプレイ、入出力装置あるいはプラズマディスプレイ等の表示装置向け透明電極もしくは反射電極の電極基板、あるいは太陽電池用の透明電極もしくは反射電極に係わり、特に薄膜で導電性と可視光透過率が高く、しかも保存安定性に優れた電極基板に関するものである。

【0002】

【従来の技術】ガラス、プラスチックフィルム等の基板上に、可視光線を透過する電極形状の透明導電膜が設けられた電極板は、液晶ディスプレイ等の各種表示装置の表示用電極やこの表示装置の表示画面から直接入力する入出力電極などに広く使用されている。例えば、液晶が用いられたディスプレイ装置の透明電極板は、図1に示すように、ガラス基板31、このガラス基板31上の両面部位に設けられた両素極にその透過光を赤、緑、青にそれぞれ着色するカラーフィルタ層37と、上記ガラス基板31上の両素と両素との間の部位（両素間部位）に設けられこの部位からの光透過を防止する遮光膜38と、上記カラーフィルタ層37の全面に設けられた保護層39と、この保護層39上に成膜された透明電極40と、この透明電極40上に成膜された配向膜41とで構成されている。

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ITO薄膜が広く利用されており、その比抵抗はおよそ $2.4 \times 10^{-4} \Omega \cdot \text{cm}$ で、透明電極として通常適用される240nmの膜厚の場合、その面積抵抗率はおよそ $10 \Omega/\square$ である。また、この他にも、酸化錫薄膜、この酸化錫に酸化ア、チモンを添加して構成される薄膜（ネサ膜）、酸化亜鉛に酸化アルミニウムを添加して構成される薄膜などが知られているが、これらはいずれも上記ITO薄膜よりその導電性があり、また、酸やアルカリに対する耐薬品性あるいは耐水性などが十分でない。一般には普及していない。

【0004】一方、1982年日本で開催された第7回ICVMにおいて、熱線反射膜として銀薄膜の表裏面にITO薄膜または酸化インジウム薄膜（IO薄膜）を積層させて構成される3層構造の透明導電膜が提案されている。この3層構造の透明導電膜はおよそ $5 \Omega/\square$ 程度の低い面積抵抗率を有しており、その高い導電性を生かして上記透明電極への応用が期待された。

【0005】

【発明が解決しようとする課題】ところで、上記ディスプレイ装置や入出力装置においては、近年、画素密度を増大させて緻密な画面を表示することが求められ、これに伴って上記透明電極パターンの微細化が要求されており、例えば100 μm 程度のピッチで上記透明電極の端子部を構成することが要求されている。また、液晶ディスプレイ装置において基板に液晶駆動用ICが直接接続される方式（COG）においては、配線の引き回しが幅20〜50 μm という細線となる部分があり、従来の高いエッチング加工適性と高い導電性（低い抵抗率）が要求されている。

【0006】また、その一方で表示画面の大型化も求められており、このような大画面化について上述したような緻密パターンの透明電極を形成し、しかも液晶に十分な駆動電圧を印加できるようにするためには、上記透明電極として $5 \Omega/\square$ 以下という高い導電性を備えた透明導電膜を適用する必要がある。また、これに加えて、STN液晶等を利用した単純マトリクス駆動方式の液晶表示装置において16階調以上の多階調表示を行う場合には $3 \Omega/\square$ 以下というさらに低い面積抵抗率が要求されている。

【0007】しかしながら、第7回ICVMにおいて提案された上記3層構造の透明導電膜においても、高々 $5 \Omega/\square$ 程度の面積抵抗率が得られるに過ぎず、十分な導電性が確保できないという問題点があった。なお、銀薄膜の厚さを16〜18nm程度に厚くすることによりその面積抵抗率を約 $3 \Omega/\square$ に低下させることは可能であ

分と化合しやすい、その表面に反応物を生成して凹凸の欠陥を生じ、例えば液晶表示装置の透明電極に適用した場合にはその表面に凹凸欠陥などを生じやすいという問題点があった。本発明はこのような問題点に着目してなされたものであって、その課題とするところは、薄膜で導電性及び可視光線透過率が高く、しかも経時劣化がなく保存安定性に優れた透明導電膜を提供することにある。

【0009】一方、太陽電池用透明電極においては、その製造プロセスの関係で水素プラズマ耐性を必要とする。このため、水素プラズマ耐性の高い酸化亜鉛を基材とする透明電極を用いることが一般的である。しかし、酸化亜鉛系の透明電極は、酸素下で処理したものや、アルミナ添加したものでも抵抗値が高く、太陽電池用透明電極として400nm～800nmとかなり厚い膜厚にて形成する必要があった。

【0010】本発明者らは、これらの問題をほぼ解消する電極基板として、例えば、0.1～3at%銅を含有する銀系薄膜を透明酸化物質薄膜で挟持する構成の導電膜を形成した電極基板を提案している。しかし、この構成は、ほぼ実用レベルにあるが耐湿性がやや不十分であった。銅を1at%含有する銀系薄膜を透明酸化物質薄膜で挟持する構成の導電膜（以下、3層電極と略す）付き電極基板を、60℃、95%湿度の高温高湿環境下にて保管すると、およそ200時間前後でパターンに微小のヒビが発生してしまう問題があった。

【0011】

【課題を解決するための手段】上述のような技術的課題に鑑みて本発明者らが鋭意検討を重ねたところ、高屈折率かつ耐湿性に優れた絶縁膜を、保護膜として3層電極上に形成した構成が良い結果を得ることを発見した。屈折率については、保護膜に限らず、銀系薄膜を挟持する透明酸化物質薄膜においても同様に高いことが好ましい。この傾向は、空気よりも屈折率の高い液晶材料（通常の液晶の屈折率は1.5～1.6程度）やカラーフィルタ（カラーフィルタの材料の屈折率は1.5を若干超える程度）と接する形態の3層電極の場合に顕著である。

【0012】例えば、ガラス等の基板上に形成された3層電極の片側が空気である場合のシミュレーション結果を図4のA線図に示すが、透過率Tは100%以上、反射率Rは1%に近いところまで下がる。ここでは基板側の透明酸化物質薄膜の膜厚を40nm、Ag膜厚を14nm、空気と接する側の透明酸化物質薄膜の膜厚を44nmとした。透明酸化物質薄膜の屈折率を1.10とほぼ同じ2.0として計算した。しかし、3層電極上にポリイミドの配向膜を40nm積層し、これに接する液晶の屈折率を1.5として計算し直すと、図4のAに示すように透過率Tと反射率Rはかなり悪くなる。透過率のピークは90%を下回り、反射率Rは、光の波長550nm

m付近でおよそ10%まで上昇してしまう。

【0013】本発明者らは、このことから、3層電極に液晶の配向膜としてのポリイミド膜と液晶が接する形での計算を、透明酸化物質薄膜の屈折率を変えて（屈折率を変えると同時に銀系薄膜を挟持する透明酸化物質薄膜の膜厚も調整し、ほぼ最適化した）行なった。結果を図3に示す。透明酸化物質薄膜の屈折率が高い方が、特に2.1を超えると透過率が向上し、また、反射率も低下することがわかる。

【0014】このように、本発明者らは、3層電極において、銀系薄膜の膜厚に対応して透明酸化物質薄膜の膜厚を調整することによって、その透過率の最適化が可能であることを見出している。本発明者らはさらに、この透明酸化物質薄膜は、一部を高屈折率の絶縁膜によって置き換えることが可能であることを発見した。絶縁膜による置き換えで3層電極の信頼性が大きく向上することを併せて発見した。すなわち、請求項1に係わる発明は、基板上に銀系薄膜を透明酸化物質薄膜で挟持する構成の導電膜を備える電極基板において、上記導電膜上に屈折率が2.1より大きい絶縁膜を配設してなることを特徴とする電極基板である。

【0015】酸化セリウムは、強い耐アルカリ性をもつと同時に、約2.5の極めて高い屈折率をもつ。透明酸化物質薄膜の膜厚の一部を代替する形で、酸化セリウムを基材とする絶縁膜を用いることができる。すなわち請求項2に係わる発明は、絶縁膜の基材が酸化セリウムであることを特徴とする、請求項1記載の電極基板である。酸化セリウムには、耐酸、耐アルカリ性に富む酸化タンタルや酸化カリウム、酸化銅など他の金属（あるいは半金属）の酸化物を添加しても良い。

【0016】絶縁膜の形成は、その膜厚を1nm～70nmの範囲に設定することが適切である。1nmより薄くても良いが、成膜時の膜厚制御及び3層電極の欠陥部を埋める効果（3層電極は微小欠陥があると、これを起点として水分などによりその構成が破壊されやすい）を合わせ考慮すると、1nmが少なくとも必要である。3層電極の透明酸化物質薄膜の片側の膜厚は、透過率や反射率を考慮するとおおむね20nm～70nmの範囲から選択される。絶縁膜での透明酸化物質薄膜の代替を行うとして、絶縁膜の最大膜厚は70nmでよい。すなわち、請求項3に係わる発明は、絶縁膜の膜厚が1nm～70nmの範囲にあることを特徴とする請求項1または2記載の電極基板である。

【0017】本発明者らは、さらに深く研究を重ねた結果、透明酸化物質薄膜の屈折率を高めていった場合において、銀系薄膜の膜厚に適切な範囲があることを見出した。透明酸化物質薄膜の屈折率を2.3とし、ガラス基板（n=1.5）側の透明酸化物質薄膜の膜厚を35nm、銀系薄膜の膜厚を12nm、上層の透明酸化物質薄膜の膜厚を37nm、ポリイミド膜の膜厚を40nm、媒質

(改晶を想定)の屈折率を1.5とした場合のシミュレーションの結果を図5に示した。銀系薄膜の膜厚の薄い方が透過率が高く、反射率は低くなり、良い傾向を示している。銀系薄膜の膜厚が1.7nmより厚くなると、光の波長550nmでの透過率は90%以上を維持することが難しくなり、1.7nmより薄く形成する必要があることがわかる。また、銀系薄膜は4nmより薄くすると、実際上、物質な膜が形成されにくく、島状の着膜となる。4nmより薄いと、こうした理由で反射率が増加するため銀系薄膜の膜厚は4nmより厚くすることが望ましい。なお、透過型LCDを前提として、高輝度の光源をバックライトとする構成では、むしろ1.7nmより銀系薄膜を厚く形成しても良い。すなわち、請求項4に係わる発明は、銀系薄膜の膜厚が4nm～1.7nmの範囲にあることを特徴とする、請求項1、2または3記載の電極基板である。

【0018】また、3層電極において、銀系薄膜の膜厚を50nmより厚く形成すると、光の反射率の高い反射電極となる。反射電極は、反射型液晶表示装置で反射板と駆動電極を兼ねた反射電極として、あるいは太陽電池で、光電変換効率を高めるために導体素子裏面に形成する光の反射膜として用いることができる。図6は、媒質の屈折率を1.5、透明酸化物薄膜の屈折率を2.3、膜厚を40nmにて、銀系薄膜の膜厚を50nm、75nm、100nm、200nmとしてシミュレーションしたものである。銀系薄膜の膜厚が50nmを超えると80%前後の反射性電極となり、200nmで反射率が飽和し、透過率もほぼ0%となることが示されている。すなわち、請求項5に係わる発明は、銀系薄膜の膜厚が50nm～200nmの範囲にあることを特徴とする、請求項1、2または3記載の電極基板である。

【0019】なお、反射電極を形成する基板は、透明であっても良いが、白、黒その他の色に着色された基板であっても良い。材質も、ガラス、プラスチック、フィルム、セラム、金属あるいはアモルファス、非晶の半導体素子が形成された基板など、種々のものが使用できる。

【0020】ところで、ITO-Ag-ITOの構成に代表される従来の3層電極は、耐湿性に大きな問題がある。また、ITOは屈折率が1.8～2.0程度であるため、高性能の3層電極を提供できるものではない。本発明者らは、種々の酸化物を検討した結果、酸化セリウムと酸化インジウムとの混合酸化物を3層電極の透明酸化物薄膜として用いる構成が、耐湿性及び光学特性において極めて優れていることを見出した。すなわち、

酸化物として含有する金属元素換算（酸素元素をカウントしない）で、セリウム元素を5at%以上、好ましくは20at%以上、酸化インジウムに加えることにより、3層電極としてほぼ実用レベルの導電膜を備える電極基板を提供できる。3層電極としてパターン形成が必要な場合は、ウエットエッチングを前提とすると、セリウム元素の添加量は4.0at%以下が良い。4.0at%以上となると、ウエットエッチングでのパターン形成がやや難しくなる。4.0at%以上の添加量でも、ドライエッチングの場合はこの問題はない。また、パターン形成が不要な場合は、セリウム元素を4.0at%を超えるレベルでの混合酸化物としても良い。透明酸化物薄膜の屈折率は、酸化セリウムの割合が高くなるにつれて高い屈折率となる。本発明者らのデータでは、セリウム2.0at%で $n=2.17$ 、3.0at%で $n=2.24$ 、4.0at%で $n=2.30$ 、10.0at%で $n=2.49$ であった。なお、これらの屈折率は成膜時の酸素ガスの分圧や成膜後のアニール温度条件などにより影響を受ける。

【0022】本発明による電極基板は、表示装置用電極基板として用いる場合に、基板と透明電極である3層電極との間には、赤、緑、青などに着色されたカラーフィルタを配設することによりカラー表示を可能とする。すなわち、請求項7に係わる発明は、基板と導電膜との間にカラーフィルタが配設されていることを特徴とする、請求項1、2、3、4または6記載の電極基板である。

【0023】

【発明の実施の形態】本発明の実施の形態を、以下の実施例に述べる。

【0024】

【実施例】以下、本発明の実施例を図面を参照して詳細に説明する。

【実施例1】この実施例に係る電極基板1は、図1

(a)に示すように、厚さ0.7mmのガラス基板11と、フタライズパターン状の透明電極として厚さ40nmの透明酸化物薄膜12と、厚さ15nmの銀系薄膜13と、厚さ40nmの透明酸化物薄膜14と、第3層電極のパターンを備える1に厚さ2nmの酸化セリウムである絶縁膜15を形成して、液晶表示装置に電極基板とした。

【0025】透明酸化物薄膜12、14はいずれも金属元素換算（酸素元素をカウントしない）でセリウムを3.0at%含む、酸化セリウムと酸化インジウムの混合酸化物とした。銀系薄膜は銅を0.8at%含む銅合金とした。いずれもスパッタリングにて成膜し、ウエットエッチングにてパターン形成したものである。酸化セリウム

【0026】透明酸化物薄膜12、14はいずれも金属元素換算（酸素元素をカウントしない）でセリウムを3.0at%含む、酸化セリウムと酸化インジウムの混合酸化物とした。

【0027】本実施例の電極基板を、図1(b)に示すように、

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—以外の部分でガラス基板が露出した基板では、5～6%の反射率である。逆に、透過型液晶表示装置の場合、ガラス部からの反射成分を抑える必要があるが、酸化セリウムの膜厚を5 nm以下にして形成せしめればガラス基板のみとほぼ同程度の反射率を得ることができる。

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【発明の効果】本発明によれば、屈折率が2.1より大きい絶縁膜を3層電極上に配設するため、透明電極においては高透過率を維持したまま、耐湿性を向上することができる。また、反射電極においては、高反射率を維持したまま、耐湿性を向上することができる。また、ノーマリホワイト表示の反射型液晶表示装置向け電極基板としては、電極パターン以外の、例えばガラス部からの反射も期待できるため、更なる輝度向上が図られる。また、透明酸化物質膜の膜厚の一部を酸化セリウムで置き換えることができるため、高価な酸化インジウムの使用量を減らすことができる。

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【図1】 (a)は実施例1に、(b)は実施例2に、それぞれ係る電極基板の断面図である。

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【図3】本発明に係る電極基板の、透明酸化物薄膜の屈折率を変えた場合の分光反射率と分光透過率を示すグラフである。

【図4】電極基板のシミュレーションにおいて、媒質の屈折率が1であるときと1.5であるときの分光特性の差を示すグラフである。

【図5】本発明に係わる電極基板の、銀系薄膜の膜厚を薄い領域で変えた場合の分光特性を示すグラフである。

【図6】本発明に係る電極基板の、銀系薄膜の膜厚を厚い領域で変えた場合の分光特性を示すグラフである。

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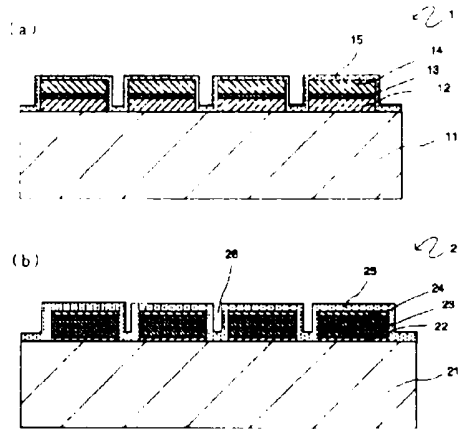
12、14、22、24：透明氧化物薄膜

13、23：銀系薄膜

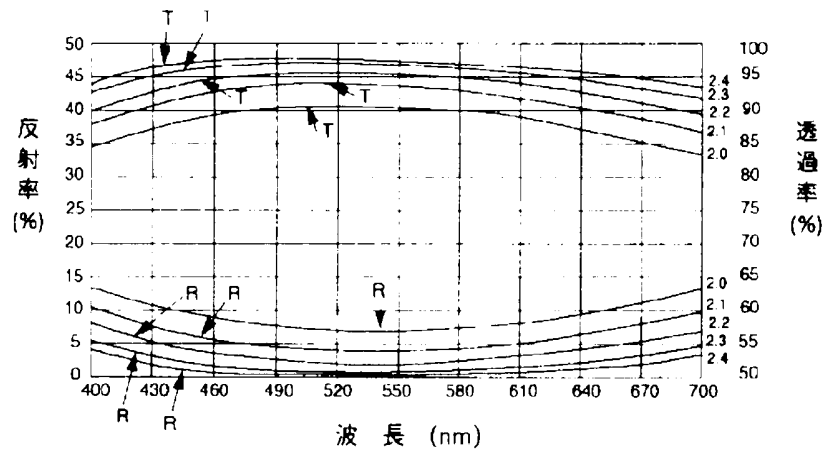
15、25 絶縁膜

[illegible]

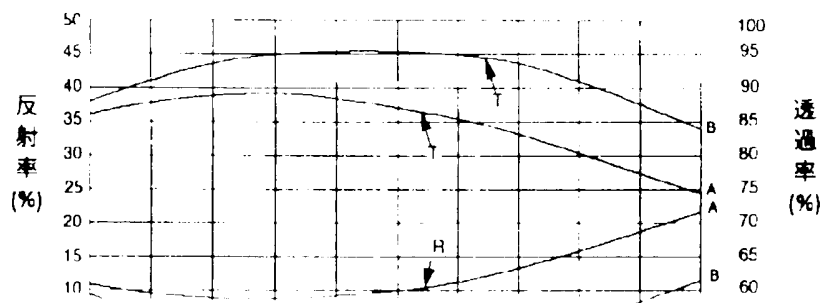
【図1】



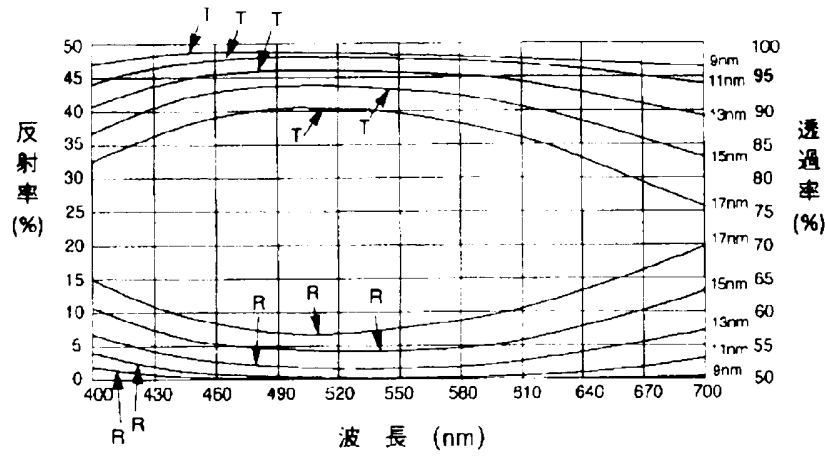
【図3】



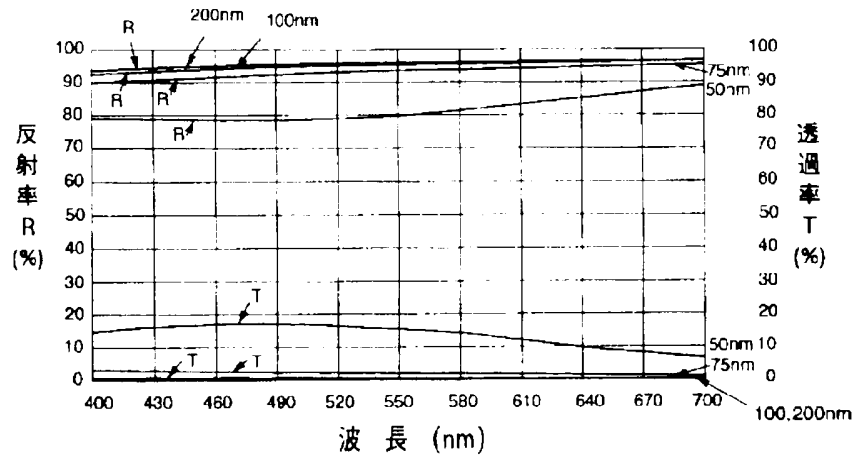
【図4】



【図5】



【図6】



フロントページの続き

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